

PATENT APPLICATION Attorney Docket No.: Q60118

THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 1752

Examiner: C. Hamilton

In re application of

Kazuyoshi MIZUTANI et al.

Appln. No.: 09/615,708

Confirmation No.: Not yet assigned

Filed: July 13, 2000

BOTTOM ANTI-REFLECTIVE COATING MATERIAL COMPOSITION AND METHOD FOR FORMING RESIST PATTERN USING THE SAME

SUPPLEMENTAL AMENDMENT

Commissioner for Patents Washington, D.C. 20231

Sir:

For:

Please amend this application as follows:

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IN THE CLAIMS:

Please enter the following amended claims:

Claim 19. (Amended) A bottom anti-reflective coating material composition as claimed in claim 12, wherein said polymer light absorbent contains from 2 to 50 wt% of a repeating structural unit represented by formula (XXVII) of claim 18 where B₁ is a group obtained by the reaction of a group represented by -CONHCH₂OH, -CONHCH₂OCH₃, -CH₂OCOCH₃, -CGH₄(OH)CH₂OH, -C₆H₄(OH)CH₂OCH₃ or -CONHC(CH₃)₂CH₂COCH₃, with formalin.

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